



Attorney's Docket 040258-0280192
Client Reference: EL00028CDC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
TOMOHISA HOSHINO ET AL.

Confirmation Number: 5539

Application No.: 09/835,820

Group Art Unit: 2825

Filed: April 17, 2001

Examiner: Luu, Chuong A.

For: FABRICATING PROCESS OF A SEMICONDUCTOR DEVICE INCL UDING A
CVD PROCESS OF A METAL FILM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

FEES

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been
calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	16	-	20	= 0	\$ 18.00 = \$ 0.00
INDEP.	3	-	3	= 0	\$ 86.00 = \$ 0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+ \$ 290.00	= \$ 0.00
TOTAL ADDITIONAL CLAIM FEE					\$ 0.00
GRAND TOTAL					\$ 0.00

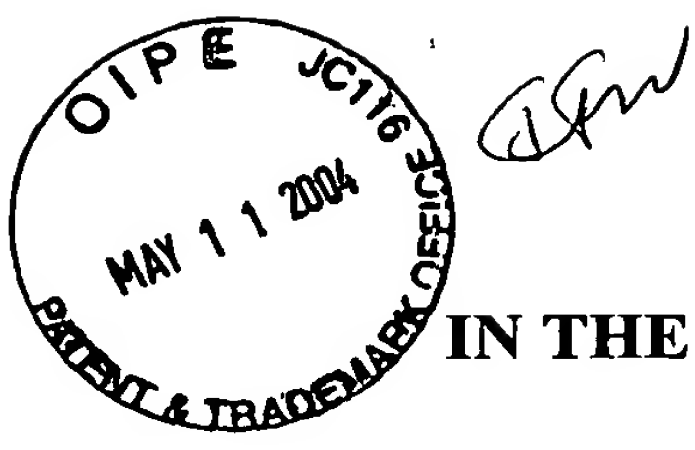
FEE PAYMENT

Authorization is hereby made to charge the amount of \$0.00 to Deposit Account No.
033975. Charge any additional fees required by this paper or credit any
overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: May 11, 2004
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2825



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May 11, 2004

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AMENDMENT

Hon. Commissioner of Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313

Sir:

In response to the Office Action dated March 17, 2004, please amend the above
identified application as follows.